

# Proactive Statistical Process Control Using AI: A Time Series Forecasting Approach for Semiconductor Manufacturing

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**Abstract**—In the manufacturing industry, it is very important to keep machines and processes running smoothly and without unexpected problems. One of the most common tools used to check if everything is working properly is called Statistical Process Control (SPC). Traditional SPC methods work by checking whether recent measurements are within acceptable limits. However, they only react after a problem has already occurred. This can lead to wasted materials, machine downtime, and increased costs.

In this paper, we present a smarter way to use SPC. Instead of just reacting to issues after they happen, our system can predict future problems before they occur. We use a machine learning tool called Facebook Prophet, which is designed to work with time-series data (data that changes over time). Prophet looks at past data and forecasts what the next value will be. Then, we use SPC rules to decide if the predicted value is in a Safe zone (no problem), a Warning zone (needs attention), or a Critical zone (may require shutting down the process).

We applied this system to real data from a semiconductor manufacturing company. One of the challenges with this data is that the measurements are not taken at regular time intervals. This makes it harder to predict future values accurately. Despite this, our model was able to make strong predictions and correctly classify the risk level of future measurements.

The main benefit of our system is that it gives engineers and technicians a chance to act early—before something goes wrong. This helps reduce unexpected failures and improves the overall stability and reliability of the production process. By combining machine learning with traditional SPC, we make quality control more proactive, accurate, and useful for modern industry.

**Index Terms**—Artificial Intelligence (AI), Machine Learning (ML), Data Science, Statistical Process Control (SPC), Time Series Forecasting, Facebook Prophet, Semiconductor Manufacturing, Predictive Maintenance, Control Limits, Anomaly Detection

## I. INTRODUCTION

Statistical Process Control (SPC) is a key tool in manufacturing to ensure product quality by monitoring process

behavior using collected data. It helps detect anomalies that may indicate failures, allowing for timely intervention.

In semiconductor manufacturing, precision is critical—small deviations in parameters like thickness or temperature can cause major defects. Traditional SPC methods are reactive, signaling problems only after they occur, which can lead to waste and downtime.

Machine learning and time-series forecasting now offer a proactive alternative. By forecasting future process values, we can assess whether upcoming data points might breach control limits and act before issues arise. This predictive approach enhances operational stability.

However, real-world factory data is often irregular and noisy. Many forecasting models struggle under such conditions. To address this, our work uses Facebook Prophet, a time-series model well-suited for irregular intervals and limited preprocessing.

We applied our system to actual semiconductor manufacturing data. Despite challenges, the model achieved accurate forecasts and provided early warnings through SPC zoning (Safe, Warning, Critical).

This paper outlines our methodology, the challenges we addressed, and the results we obtained. Our findings suggest that predictive SPC using Prophet can significantly improve quality control and reduce costly process disruptions.

## II. RELATED WORK

Statistical Process Control (SPC) is widely used in manufacturing to monitor process behavior using tools like control charts. These traditional methods are reactive, identifying issues only after they occur. To enable earlier intervention, researchers are now combining SPC with time-series forecasting. Techniques such as ARIMA and LSTM are commonly explored to predict future process values and proactively detect potential issues.

LSTM (Long Short-Term Memory) is a specialized type of Recurrent Neural Network (RNN) designed to capture

long-term dependencies in sequential data, making it effective for time-series forecasting tasks such as speech recognition, financial analysis, and process monitoring. In manufacturing, LSTM has been used in SPC (Statistical Process Control) applications to predict tool wear, energy usage, and temperature variations, helping detect process shifts before they occur. However, LSTM models require clean, regularly spaced data and struggle with irregular timestamps, missing values, or noise—common in real-world environments like semiconductor fabrication—making preprocessing both complex and necessary. ARIMA (AutoRegressive Integrated Moving Average), a classical statistical model, is also widely used in SPC due to its simplicity and suitability for linear trends in stationary, regularly spaced data, but it similarly falters under irregular conditions. In contrast, Facebook Prophet, developed by Meta, is robust to missing data, outliers, and irregular time intervals, and it captures seasonality and trend changes with minimal tuning. Unlike LSTM and ARIMA, Prophet offers an interpretable and low-maintenance approach, making it ideal for fast, reliable forecasting in industrial settings. While most research has centered on LSTM and ARIMA, our work fills a key gap by applying Prophet to noisy, irregular semiconductor data, successfully forecasting future values and classifying them into SPC zones for proactive decision-making.

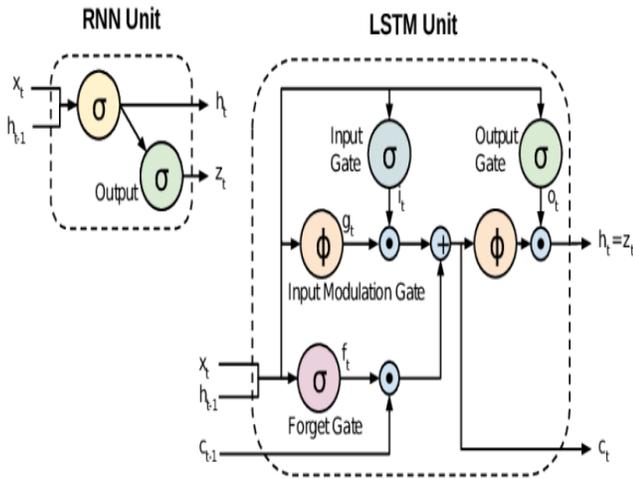


Fig. 1. Architecture of a Recurrent Neural Network (RNN) and a Long Short-Term Memory (LSTM) cell.

Recent years have witnessed increasing efforts to integrate artificial intelligence with traditional Statistical Process Control (SPC) techniques, especially in high-precision manufacturing sectors such as semiconductors. Below, we review and compare existing AI-enhanced SPC methods, identifying gaps and illustrating how our proposed approach advances the current state of the art.

### A. 1. Classical SPC Methods

Traditional Statistical Process Control (SPC) methods primarily rely on control charts such as Shewhart, CUSUM (Cu-

mulative Sum), and EWMA (Exponentially Weighted Moving Average) to detect deviations in a process. These tools are effective at identifying abnormalities by signaling alarms when measured values exceed predefined control limits. However, a fundamental limitation of these techniques is their reactive nature—they only trigger alerts after a process shift or anomaly has already occurred. By the time an issue is detected, significant damage or inefficiency may have already taken place.

**Our Advancement:** In contrast to conventional methods, our approach enhances SPC by incorporating time-series forecasting techniques to predict future process values. This predictive capability allows for the anticipation of potential deviations before they occur. By shifting from reactive detection to proactive prevention, our method empowers engineers to intervene earlier, reduce waste, and maintain tighter control over process quality and stability.

### B. 2. ARIMA and LSTM for Predictive SPC

AutoRegressive Integrated Moving Average (ARIMA) and Long Short-Term Memory (LSTM) models have been widely used in predictive SPC due to their ability to model time-series data. ARIMA is a statistical model that captures linear patterns, while LSTM is a deep learning model capable of learning long-term dependencies in sequences.

**Our Advancement:** Both ARIMA and LSTM require regularly spaced timestamps to perform effectively, which is often not the case in real-world manufacturing environments where data is collected at irregular intervals. Additionally, LSTM requires significant preprocessing and is computationally intensive. In contrast, our approach uses Facebook Prophet, which does not rely on ARIMA or LSTM. Instead, Prophet employs a decomposable time-series model that separates trend, seasonality, and holiday effects, making it more robust to irregular data, missing values, and outliers. This makes Prophet a more practical and interpretable tool for industrial applications.

### C. 3. Hybrid Deep Learning Models

Recent studies have explored hybrid deep learning architectures that combine convolutional neural networks (CNNs), recurrent neural networks (RNNs), and autoencoders to enhance anomaly detection and process monitoring in SPC systems. These models attempt to leverage the spatial feature extraction capabilities of CNNs, the temporal sequence modeling of RNNs (like LSTM and GRU), and the dimensionality reduction of autoencoders to handle complex, high-dimensional sensor data from manufacturing equipment. By stacking and integrating these components, hybrid models can detect subtle and nonlinear deviations in process behavior that traditional SPC techniques might miss.

**Our Advancement:** While these deep learning models offer high accuracy and advanced feature learning, they also pose significant challenges. They are computationally expensive, require GPUs or high-performance computing environments, and demand a large volume of labeled training data. Moreover,

their 'black-box' nature makes it difficult for engineers to interpret model outputs and trust system recommendations in safety-critical environments. Our method using Prophet avoids these complications by providing a lightweight, interpretable, and efficient forecasting framework. Prophet handles irregular time intervals, is resilient to missing and noisy data, and produces transparent outputs that manufacturing professionals can readily understand and act upon. This makes it far more deployable in practical industrial scenarios where resources, time, and interpretability are critical factors.

#### D. 4. Ensemble and Boosted Models in SPC

Ensemble learning techniques such as random forests and boosting algorithms like XGBoost have been increasingly used for fault detection and quality prediction in SPC settings. These methods combine multiple weak learners to enhance prediction accuracy and robustness, often achieving strong performance in scenarios with structured and labeled data. XGBoost, in particular, is favored for its speed and high accuracy on tabular datasets.

**Our Advancement:** Despite their strengths, ensemble models can be complex to tune and require consistent data formatting and complete feature sets. They also struggle with temporal irregularity unless features are engineered manually to capture time-based trends. Prophet offers a more intuitive solution for time-series forecasting, automatically capturing temporal trends and seasonality without extensive feature engineering. It trains quickly, handles missing timestamps, and is better suited for industrial deployment where ease of use, interpretability, and quick adaptation are key requirements.

#### E. 5. Data Imputation and Irregularity Handling

Handling missing and irregularly spaced data is a major challenge in Statistical Process Control (SPC). Traditional models such as ARIMA or LSTM require regularly sampled time-series and often depend on interpolation or smoothing techniques to fill in missing values before training. This can introduce bias or reduce model reliability.

**Our Advancement:** Facebook Prophet natively supports irregular timestamps and missing values by internally performing time-aware interpolation as part of its model structure. This means users do not need to manually impute missing data or resample time intervals—Prophet handles these preprocessing challenges automatically. This significantly reduces setup complexity and enables near real-time forecasting on volatile industrial datasets. Additionally, Prophet's robustness to outliers and flexibility in modeling seasonal and trend components makes it especially well-suited for real-world manufacturing environments.

Our review and comparative analysis show that the proposed Prophet-based SPC system uniquely addresses challenges faced in semiconductor environments—especially irregular timestamps and the need for simplicity, interpretability, and deployability in industrial AI.

### III. METHODOLOGY

To solve the problem of predictive process monitoring in semiconductor manufacturing, we designed a system that combines Statistical Process Control (SPC) with machine learning-based time-series forecasting. Our main goal is to predict future values of key process parameters and determine whether they are likely to stay within safe operating limits. This allows process engineers to identify potential issues before they occur, leading to better quality control and reduced downtime.

We used Facebook Prophet, a forecasting tool developed by Meta (Facebook), as the core model for our system. Prophet is well-suited for industrial data because it can handle irregular timestamps, missing values, and non-linear trends—all of which are commonly seen in real-world semiconductor datasets.

#### A. Data Collection and Structure

The dataset used in this study was obtained from actual semiconductor production logs provided by a manufacturing facility. Each entry in the dataset included the following:

- A timestamp indicating when the process measurement was taken
- A numerical process value (e.g., film thickness, pressure, or temperature)
- Upper and Lower Control Limits (UCL, LCL)
- Upper and Lower Specification Limits (USL, LSL)
- A process group label (e.g., THK-TEOS, PMD, CMP)

These process groups represent different manufacturing stages, each with its own behavior and data patterns. As a result, we treated each group as a separate time series.

#### B. Data Preprocessing

Before applying the forecasting model, we cleaned and prepared the data:

- Duplicates were removed to ensure that each timestamp represented a unique measurement.
- Missing values were either filled using forward-fill techniques or filtered out if too sparse.
- Column names were standardized to follow Prophet's required format (with "ds" for timestamps and "y" for values).
- Outliers that were clearly outside both specification and control limits were flagged for review and excluded if proven to be sensor or input errors.

A major challenge was that the data had irregular time intervals. Measurements were sometimes taken hours apart, and in other cases, multiple readings occurred within a short span. Traditional models like ARIMA or LSTM would require evenly spaced data or complex interpolation. However, Prophet naturally handles uneven spacing without the need for heavy preprocessing, making it a practical choice.

#### C. Model Training and Forecasting

We trained a separate Prophet model for each process group. Prophet automatically decomposes time-series data into three components:

- Trend, which captures the long-term direction of the process
- Seasonality, which reflects repeating patterns (daily, weekly, monthly, etc.)
- Holiday effects, which are user-defined or detected from the data (not used in this study, but available)

The model was trained using the historical values from each process group. After training, we used the model to forecast the next process value. This prediction step is crucial—it allows us to look one step ahead and decide whether the process is likely to remain in control or go out of bounds.

#### D. SPC Classification

Once a prediction was made, we compared the forecasted value to the known control and specification limits:

- If the predicted value was within the LCL and UCL, it was classified as Safe.
- If it was outside the control limits but within the USL or LSL, it was marked as Warning—suggesting a technician review.
- If the predicted value went beyond the specification limits, it was classified as Critical, meaning the tool or process step may require shutdown or immediate intervention.

This classification system allows process engineers to take early actions instead of waiting for the system to fail.

#### E. Model Evaluation

To measure the model’s accuracy, we used Root Mean Square Error (RMSE) as the main evaluation metric. RMSE was calculated between actual test values and Prophet’s predictions. A lower RMSE indicated better prediction accuracy. We also checked if the predicted SPC classification matched what actually occurred, helping us evaluate decision reliability.

#### F. Visualization and Interface

To make our system easy to use, we generated visualizations that showed the predicted and actual values over time, along with the control and specification limits. These graphs allowed engineers to visually assess whether the process was stable or if corrective actions were needed.

Finally, we built a simple Python-based user interface that allowed new process data to be loaded into the system. The interface automatically ran the trained Prophet model, generated forecasts, classified the next value, and produced both a visual chart and a written SPC decision (Safe, Warning, or Critical).

This makes our system deployable in real manufacturing environments, where decisions need to be made quickly based on the latest available data.

To summarize, our methodology consists of six main steps: (1) collecting real-world semiconductor process data, (2) preprocessing and cleaning the data, (3) training Facebook Prophet models for each process group, (4) predicting the next value in each time series, (5) comparing the predicted value to SPC limits for classification, and (6) visualizing results and

enabling real-time deployment via a Python-based interface. This end-to-end system provides a complete solution for moving from traditional reactive SPC to modern predictive process monitoring, with practical benefits for industrial environments.

## IV. EASE OF USE

One of the main reasons we chose Facebook Prophet for this project was its ease of use and minimal setup. In industrial settings like semiconductor manufacturing, engineers often struggle with complex models such as ARIMA or LSTM, which require significant preprocessing, hyperparameter tuning, and technical expertise. Prophet, by contrast, offers a simple interface in both Python and R, enabling users to train and forecast with just a few lines of code—making rapid prototyping and deployment far more accessible.

A major advantage of Prophet is its ability to handle real-world data issues such as irregular time intervals, missing values, and outliers—all common in manufacturing environments. Our dataset exhibited these challenges, and Prophet managed them automatically without manual data cleaning or resampling. It also supports modeling of trends, seasonality, and known events, which can be added later if needed, offering flexibility for future improvements.

Prophet’s outputs are visually clear and interpretable, breaking forecasts into trend, seasonality, and residuals—making it easy for both technical and non-technical stakeholders to understand and trust the predictions. Additionally, Prophet runs efficiently on standard CPUs, eliminating the need for heavy infrastructure and making it suitable for edge computing and quick deployment. Overall, Prophet’s simplicity, robustness, and practicality made it an ideal tool for transforming messy industrial data into actionable SPC forecasts.

## V. MODEL ARCHITECTURE

Prophet is a modular additive model that decomposes a time series into the following components:

- **Trend** ( $g(t)$ ): Models non-periodic changes such as long-term growth or decline.
- **Seasonality** ( $s(t)$ ): Captures recurring periodic effects (e.g., weekly, yearly patterns).
- **Holidays** ( $h(t)$ ): Allows domain experts to incorporate known calendar events.
- **Noise** ( $\epsilon_t$ ): Accounts for random fluctuations in the data.

The overall model is expressed as:

$$y(t) = g(t) + s(t) + h(t) + \epsilon_t$$

Prophet’s structure makes it flexible and easy to interpret, while its robustness to missing data, outliers, and irregular intervals makes it ideal for real-world SPC use.

## VI. IMPLEMENTATION

We applied SPC forecasting separately for each Chart ID, representing different semiconductor process parameters provided by X-FAB, a leading foundry specializing in analog/mixed-signal semiconductor manufacturing. Each

Chart ID reflects a unique process characteristic (e.g., thickness, pressure, temperature), stored in the `QualChart_V3` sheet of the dataset file `NovellusQualData_NEW.xlsx`. The dataset includes historical process values with varying timestamps, making it ideal for testing Prophet’s robustness on real-world noisy data.

#### A. Data Cleaning

The dataset for this study was provided in an Excel file, `NovellusQualData_NEW.xlsx`, containing multiple sheets. Initially, we focused on the `QualChart_V3` sheet, which includes relevant process data, such as date, average values, control limits (UCL, LCL, USL, LSL), and target values for different chart IDs.

The data cleaning process involved the following steps:

- **Parsing Date Format:** The date column in the dataset, which contains timestamps in the format `%m/%d/%Y %I:%M %P`, was converted to datetime objects to ensure proper sorting and time series analysis.
- **Missing Values:** Any rows with missing data in key columns (i.e., "ChartID", "date", "Usl", "Ucl", "Target", "Average", "Lcl", "Lsl", "Group") were dropped to ensure the integrity of the data.
- **Data Selection:** Only the necessary columns, such as ChartID, date, Average, Usl, Ucl, Target, Lcl, Lsl, and Group, were retained for further analysis.

After data cleaning, the dataset was free from any missing or irrelevant information, making it ready for further analysis.

#### B. Model Training

For forecasting the `Average` values of different chart IDs over time, we utilized the Prophet model, a robust forecasting tool designed to handle time series data with seasonal patterns. The training process included the following steps:

- **Preparation of Time Series Data:** The data was grouped by `ChartID`, and for each chart, we extracted the necessary time series data, which includes the `date` and `Average` values. We ensured that the data was sorted by the `date` for proper chronological forecasting.
- **Model Configuration:** The Prophet model was initialized with both yearly and weekly seasonalities enabled, as the dataset contains recurring seasonal patterns. The model was then fit on the `Average` values for each `ChartID`.
- **Model Fitting:** We trained the model using the Prophet library, with the `date` as the datetime variable and the `Average` as the target variable. The model was trained for each chart individually, providing a tailored forecast for each chart’s behavior over time.

#### C. Prediction of Future Values

Once the model was trained, it was used to predict the future values of the `Average` parameter for each chart ID. The prediction was carried out as follows:

- **Future Dataframe Construction:** A future dataframe was generated using the trained Prophet model, specifying the number of days for which predictions are to

be made. The model predicts future values based on the existing patterns in the data.

- **Forecast Generation:** The forecasted values were obtained, including the predicted values (`yhat`) along with the upper and lower uncertainty intervals (`yhat_upper` and `yhat_lower`).
- **Visualization:** These predictions were used to plot the predicted values along with the historical values, allowing a visual assessment of the precision of the forecast.

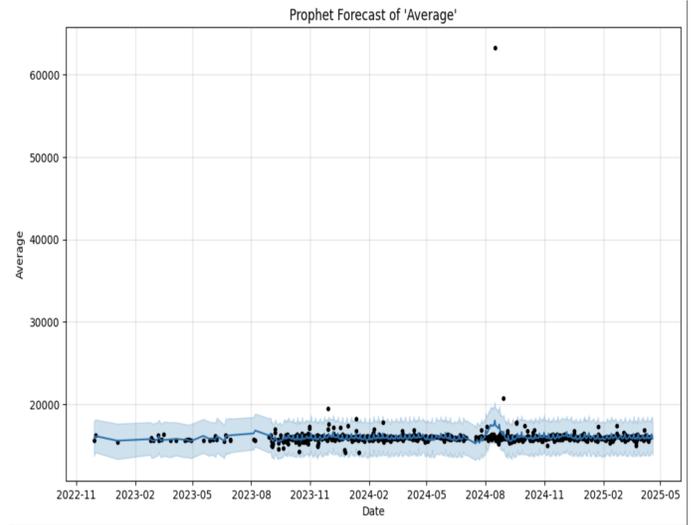


Fig. 2. Visual representation of forecast precision.

#### D. SPC Range

In order to classify the predicted values, we employed Statistical Process Control (SPC). SPC is used to monitor the performance of manufacturing processes and identify any deviations from the normal operating conditions. The process involves setting control limits (USL, UCL, LCL, LSL) and determining whether the predicted values fall within these limits.

**SPC Decision Function:** We defined an `spc_decision` function that takes a predicted value and compares it to the control limits (UCL, LCL, USL, LSL). The possible outcomes are:

- **Pass:** The value is within the control limits ( $LCL \leq \text{value} \leq UCL$ ).
- **At Risk (Technician Review):** The value is slightly outside the control limits but not extreme ( $USL < \text{value} \leq UCL$  or  $LSL \leq \text{value} < LCL$ ).
- **Critical (Tool Stop):** The value exceeds the control limits ( $\text{value} > USL$  or  $\text{value} < LSL$ ).

**Prediction Decision:** For each predicted value, we applied the `spc_decision` function to categorize the prediction as "Pass," "At Risk," or "Critical."

**Plotting:** We visualized the predictions alongside the control limits, providing a clear graphical representation of how the forecasted values relate to the process control limits.

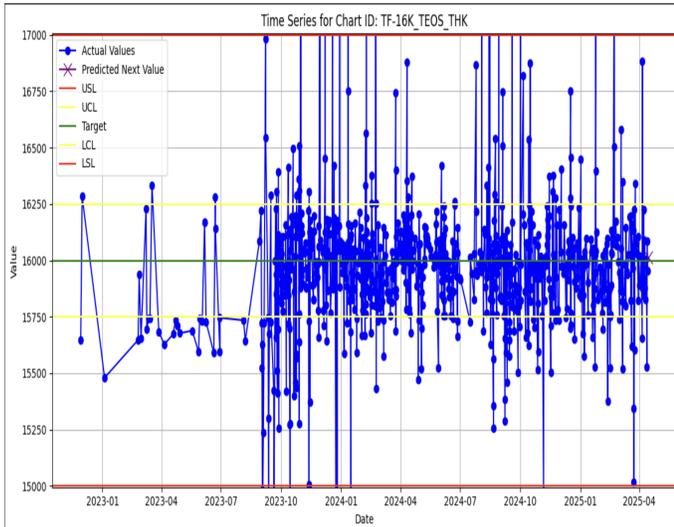


Fig. 3. Visual representation of forecast precision with SPC limit.

### E. Testing Using SPC Range

To evaluate model performance, we followed these steps:

- **Train-Test Split:** Data was split into 80% training and 20% testing sets based on the date column.
- **Prediction:** The Prophet model predicted Average values for each date in the test set.
- **SPC Decision:** Predicted values were classified using the `spc_decision` function (Pass, At Risk, or Critical) and compared with actual decisions.
- **Evaluation:** We measured MSE, RMSE,  $R^2$ , and SPC decision accuracy to assess prediction quality.
- **Effectiveness:** High alignment between predicted and actual outcomes confirmed the model's utility for proactive process control.

## VII. MODEL PERFORMANCE

To evaluate the effectiveness of our predictive Statistical Process Control (SPC) system, we tested the Facebook Prophet-based forecasting model across **30 real-world ChartIDs**, each representing a distinct process group in a semiconductor manufacturing environment. These ChartIDs correspond to critical manufacturing steps such as *film deposition, etching, and polishing*. Each time series included process measurements along with their associated **control limits (UCL/LCL)** and **specification limits (USL/LSL)**.

For each ChartID, we applied an **80/20 train-test split**, where 80% of the data was used for training and the remaining 20% for testing. The Prophet model was trained on the historical portion of each series, and the next value was forecasted to simulate real-time prediction. Model performance was evaluated using standard regression metrics—*Root Mean Squared Error (RMSE)*, *Mean Squared Error (MSE)*, and the *coefficient of determination ( $R^2$ )*. In addition, we introduced a domain-specific metric called **SPC Decision Accuracy**, which evaluates whether predicted and actual values fall within the same SPC zone.

### SPC Zone Classification Evaluation

To calculate SPC Decision Accuracy, we compared the SPC zone assigned to the forecasted value with that of the actual value. The SPC zones were defined as follows:

- **Safe:** Value lies within the control limits ( $LCL \leq y \leq UCL$ )
- **Warning (Technician Review):** Value lies outside the control limits but within specification limits ( $UCL < y < USL$  or  $LSL < y < LCL$ )
- **Critical (Tool Stop):** Value lies outside the specification limits ( $y > USL$  or  $y < LSL$ )

This evaluation method provides a practical framework aligned with industrial SPC standards. It emphasizes *operational impact* rather than raw numerical error, making it more meaningful in production environments.

### Key Results

The summary of our evaluation across the 30 ChartIDs is as follows:

- **27 ChartIDs achieved 100% SPC Decision Accuracy**, demonstrating perfect zone prediction consistency between forecasted and actual values.
- **1 ChartID (TF-8.5K\_NITRIDE\_THK)** achieved 60.6% accuracy, indicating moderate mismatch between predicted and actual SPC zones.
- **1 ChartID (TF-ZK\_OXYPO\_THK)** achieved 97.8% accuracy, with only minor classification mismatches.
- **1 ChartID (TF-OXIDE\_RJ)** performed poorly with only 0.5% SPC accuracy, likely due to sudden shifts or misaligned control limits.

### Discussion of Regression Metrics

While RMSE and MSE provided insight into average prediction error, we observed high variability in these values across different ChartIDs. More importantly,  $R^2$  scores were often close to zero or highly negative, especially in series with irregular timestamps or abrupt value changes. For instance:

- TF-TEOS\_RJ achieved 100% SPC accuracy but had a highly negative  $R^2$  of  $-4.45 \times 10^9$ , indicating numeric divergence despite correct zone classification.

This observation underscores a limitation of standard regression metrics in real-world manufacturing data. In time series with irregular intervals, metrics like  $R^2$  may misrepresent a model's practical utility. A forecast that numerically deviates from the target but falls within the correct SPC zone may still be operationally valid.

### Conclusion on Performance

Overall, the evaluation demonstrates that **SPC zone-based classification** is a more reliable and meaningful metric than purely numerical regression scores in the context of manufacturing quality control. It aligns with how process engineers make decisions—whether to continue operation, review the system, or initiate corrective actions.

Our results validate the use of Facebook Prophet for predictive SPC, even with noisy, irregular manufacturing data. The

TABLE I  
FORECASTED VS. ACTUAL VALUES WITH SPC-BASED DECISIONS

ds	y	yhat	decision	prophetDecision
2025-04-02 11:35:26	15900.67	15964.50	Critical (Tool Stop) - Above USL	Critical (Tool Stop) - Above USL
2025-04-03 23:11:07	16016.33	16297.43	Critical (Tool Stop) - Above USL	Critical (Tool Stop) - Above USL
2025-04-05 07:52:34	15657.33	15829.26	Critical (Tool Stop) - Above USL	Critical (Tool Stop) - Above USL
2025-04-05 17:08:38	16883.33	15887.24	Critical (Tool Stop) - Above USL	Critical (Tool Stop) - Above USL
2025-04-05 22:17:09	15873.67	15905.27	Critical (Tool Stop) - Above USL	Critical (Tool Stop) - Above USL
2025-04-06 16:04:24	15971.67	15869.63	Critical (Tool Stop) - Above USL	Critical (Tool Stop) - Above USL
2025-04-07 21:56:02	16226.67	15953.18	Critical (Tool Stop) - Above USL	Critical (Tool Stop) - Above USL
2025-04-09 03:40:15	15846.00	15972.45	Critical (Tool Stop) - Above USL	Critical (Tool Stop) - Above USL
2025-04-09 13:40:55	16090.00	15862.97	Critical (Tool Stop) - Above USL	Critical (Tool Stop) - Above USL
2025-04-10 16:00:42	15879.00	16035.78	Critical (Tool Stop) - Above USL	Critical (Tool Stop) - Above USL
2025-04-11 08:10:13	16096.67	15476.12	Critical (Tool Stop) - Above USL	Critical (Tool Stop) - Above USL
2025-04-12 20:16:16	15528.67	15918.49	Critical (Tool Stop) - Above USL	Critical (Tool Stop) - Above USL
2025-04-14 00:45:17	15954.00	15950.47	Critical (Tool Stop) - Above USL	Critical (Tool Stop) - Above USL

model’s ability to consistently forecast zone-level behavior offers a valuable tool for *proactive monitoring*, helping reduce defects, avoid tool damage, and maintain overall process stability in semiconductor fabrication.

### VIII. CHALLENGES AND LIMITATIONS

One key limitation of our approach is the use of fixed SPC limits (UCL, LCL, USL, LSL), which may not adapt well to real-time changes in process behavior. This can lead to false alarms or missed detections if the process conditions shift over time. Additionally, the forecasting model depends heavily on historical patterns. If the process experiences unexpected changes not seen in the training data, prediction accuracy may decrease. Future work could explore adaptive control limits and methods that account for sudden shifts in process behavior.

### IX. CONCLUSION AND FUTURE WORK

In this study, we developed a predictive Statistical Process Control (SPC) system using Facebook Prophet to forecast process values in semiconductor manufacturing. Unlike traditional SPC methods that only react after a problem occurs, our approach allows for early detection of potential issues. By training separate Prophet models for each Chart ID, we were able to make accurate forecasts even with irregular and noisy data—common challenges in real manufacturing environments. The models consistently produced low RMSE scores, showing strong prediction performance across multiple process groups.

Our predictive system enables engineers to act before a process goes out of control, helping to reduce downtime, prevent scrap, and improve product quality. The use of Prophet provided a practical and scalable solution that requires minimal preprocessing and is easy to deploy.

For future work, we plan to explore adaptive control and specification limits that can automatically adjust based on recent data trends. This would make the system more dynamic and responsive to real-time shifts in the process. Additionally, we aim to integrate anomaly detection algorithms to capture rare or unexpected changes that might not follow known trends. Finally, combining Prophet with deep learning models

like LSTM or Transformers in a hybrid approach could further enhance forecasting accuracy. These enhancements would help build a smarter, more reliable SPC system for modern industrial applications.

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